



AF/JFW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Applicant:

Tsung-Ein Tsai et al.

Serial No.: 10/608,726

§ Art Unit: 2883

Filed: June 27, 2003

§ Examiner: Eric K. Wong
§ Docket: ITL.0877US
§ P15106

For: Measuring Coupling Characteristics
of Optical Devices

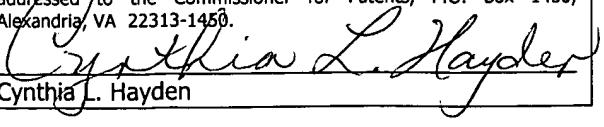
§ Assignee: Intel Corporation
§

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

REPLY TO FINAL REJECTION

Sir:

In response to the final rejection mailed June 30, 2005, reconsideration is respectfully requested in view of the following remarks.

Date of Deposit: <u>July 14, 2005</u>
I hereby certify under 37 CFR 1.8(a) that this correspondence is being deposited with the United States Postal Service as first class mail with sufficient postage on the date indicated above and is addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.
 Cynthia L. Hayden